

WEST Search History

DATE: Wednesday, June 07, 2006

Hide?	<u>Set</u> <u>Name</u>	<u>Query</u>	<u>Hit</u> <u>Count</u>
		<i>DB=PGPB; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L9	((semiconductor wafer) and controlling and \$ratio and drying and gas).clm.	0
<input type="checkbox"/>	L8	((semiconductor wafer) and controlling and \$ratio anddrying and gas).clm.	0
<input type="checkbox"/>	L7	((semiconductor wafer) and controlling and \$ratio with drying and gas).clm.	0
		<i>DB=PGPB,USPT; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L6	(semiconductor wafer) and controlling and \$ratio with drying	41
<input type="checkbox"/>	L5	(semiconductor wafer) with processing with controlling with \$ratio with drying	0
		<i>DB=EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L4	(semiconductor wafer) with processing with controlling with \$ratio with drying	1
		<i>DB=PGPB,USPT; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L3	(semiconductor wafer) with processing with controlling with \$ratio with drying	0
<input type="checkbox"/>	L2	(semiconductor wafer) with processing with controlling with (gas ratio) with drying	0
<input type="checkbox"/>	L1	(semiconductor wafer) with processing with controlling with (gas ratio) with drying with nitrogen with alcohol	0

END OF SEARCH HISTORY